

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.	:	10/565,767	Confirmation No. 2990
Applicant	:	Yuichiro Shindo	
371 Filed	:	January 24, 2006	
Art Unit	:	1793	
Examiner	:	Mark L. Shevin	
Customer No.	:	00270	
Title	:	HIGHLY PURE HAFNIUM MATERIAL, TARGET AND THIN FILM COMPRISING THE SAME, AND METHOD FOR PRODUCING HIGHLY PURE HAFNIUM	

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

This is an Amendment submitted with a Request for Continued Examination (RCE) in response to a FINAL Office Action dated August 28, 2008. A Petition for a One Month Extension of Time is filed herewith to extend the deadline for response from November 28, 2008 to December 28, 2008. Kindly amend the application as set forth below.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 5 of this paper.